

Search Notes 	Application/Control No. 10/773,854	Applicant(s)/Patent under Reexamination YEN, JEN YEN
	Examiner Ephrem Alemu	Art Unit 2821

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
315	291	4/18/2005	EA
362	802	4/18/2005	EA
367	197	4/18/2005	EA
340/815.46		4/18/2005	EA